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INFORMATION DISCUSSIONE STATEMENT BY APPLICANT

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Complete if Known				
Application Number	10/656,879			
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Filing Date	September 08, 2003			
First Named Inventor	Hideki HATANO			
Art Unit	not yet assigned			
Examiner Name	not yet assigned			
Attorney Docket Number	Q77351			

	U.S. PATENT DOCUMENTS							
	Cite	Document	Document Number					
	No.1	Number	Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document			
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	FOREIGN PATENT DOCUMENTS							
Examiner Cite Initials* No.	Cite	Foreign Patent Document			Publication Date	Name of Patentee or		
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶	
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	Photorefractive Materials for Nonvolatile Volume Holographic Data Storage, Science Vol. 282, November 6, 1998 Lambertus Hesselink, et al.				
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Examiner Signature	160 B31	121 1-4117	Date Considered	1 - 1 1

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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